



Docket No.: 50432-067

PATENT

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IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of

: Customer Number: 20277

Kai YANG, et al.

: Confirmation Number: Not Yet Assigned

Serial No.: 09/817,056

: Group Art Unit: 2811

Filed: March 27, 2001

: Examiner: T, NGUYEN

For: STABILIZING FLUORINE ETCHING OF LOW-K MATERIALS

INFORMATION DISCLOSURE STATEMENT

Mail Stop Information Disclosure Statement
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

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Dear Sir:

In accordance with the provisions of 37 C.F.R. 1.56, 1.97 and 1.98, the attention of the Patent and Trademark Office is hereby directed to the references listed on the attached form PTO-1449. It is respectfully requested that the references be expressly considered during the prosecution of this application, and that the references be made of record therein and appear among the "References Cited" on any patent to issue therefrom.

This Information Disclosure Statement is being filed within three months of the U.S. filing date OR before the mailing date of a first Office Action on the merits. No certification or fee is required.

The Morand et al. reference is believed to be an English language equivalent of the French Patent No. 2,798,512 A1 previously submitted in the Information Disclosure Statement

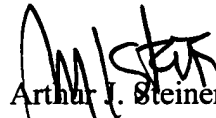
09/817,056

filed November 25, 2002. A copy of the International Preliminary Examination Report is attached for the Examiner's information.

Please charge any shortage in fees due in connection with the filing of this paper, including extension of time fees, to Deposit Account 500417 and please credit any excess fees to such deposit account.

Respectfully submitted,

MCDERMOTT, WILL & EMERY



Arthur J. Steiner
Registration No. 26,106

600 13th Street, N.W.
Washington, DC 20005-3096
(202) 756-8000 AJS:men
Facsimile: (202) 756-8087
Date: October 1, 2003

